

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventors: Jaime Poris; Claudio L. Rampoldi  
Assignee: Nanometrics Incorporated  
Title: Method Of Determining Material Using Intensity Of Light (as amended)  
Serial No.: Unknown Filing Date: August 4, 2003  
Examiner: Unknown Group Art Unit: Unknown  
Docket No.: NAN042-1D US Confirmation No.: Unknown

Santa Clara, California  
August 4, 2003

MAIL STOP PATENT APPLICATION  
COMMISSIONER FOR PATENTS  
P.O. BOX 1450  
ALEXANDRIA, VA 22313-1450

PRELIMINARY AMENDMENT

Dear Sir:

Prior to examination of the above-identified application, please amend the application as follows.

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